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CONFIRMATION NO. 4531

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/537,509	11/30/2005	438	2892	046124-5388		
RULE						
APPLICANTS Fumitsugu Fukuyo, Hamamatsu-shi, JAPAN; Kenshi Fukumitsu, Hamamatsu-shi, JAPAN; Naoki Uchiyama, Hamamatsu-shi, JAPAN; Ryuji Sugiura, Hamamatsu-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/11624 09/11/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-351600 12/03/2002 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /ELIAS ULLAH/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 24	TOTAL CLAIMS 28	INDEPENDENT CLAIMS 8
ADDRESS DRINKER BIDDLE & REATH ATTN: INTELLECTUAL PROPERTY GROUP ONE LOGAN SQUARE 18TH AND CHERRY STREETS PHILADELPHIA, PA 19103-6996 UNITED STATES						
TITLE Method for cutting semiconductor substrate						
FILING FEE RECEIVED 4830	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		